



RCB/1700

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masashi UEDA et al.

Group Art Unit: 1763

Application No.: 09/830,879

Examiner: P. Hassanzadeh

Filed: May 2, 2001

Docket No.: 109426

For: INTERNAL ELECTRODE TYPE PLASMA PROCESSING APPARATUS AND  
PLASMA PROCESSING METHOD

**LARGE ENTITY REQUEST FOR  
CONTINUED EXAMINATION UNDER 37 CFR §1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 CFR §1.114, Applicants hereby request continued examination and entry and consideration of the attached submission. The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 CFR §1.114(d).

Attached hereto is our check no. **146375** in the amount of ☒ \$750.00 as payment of the fees set forth in 37 CFR §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

Respectfully submitted,

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750.00 OP

James A. Oliff  
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JAO:GWT/gwt

Date: September 16, 2003

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<p><b>DEPOSIT ACCOUNT USE AUTHORIZATION</b> Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461</p>
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